

FORM PTO-1449 (Modified)

ATTY. DOCKET NO.

SERIAL NO.

FIS920010163US2

10/757,199

LIST OF PATENTS AND PUBLICATIONS
FOR APPLICANT'S INFORMATION
DISCLOSURE STATEMENT

APPLICANT:

DAVID CLIFFORD LONG, ET AL.

(Use several sheets if necessary)

FILING DATE:

1/14/04

GROUP:

3700

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIALS		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPRO.)
ga	AJ	6,160,469	12/12/00	Liberatore et al.			
ga	AK	6,189,200	02/20/01	Takeuchi et al.			
ga		6,459,352	10/01/02	Liu, et al.			
ga		5,884,990	3/23/99	Burghartz, et al.			
ga		6,292,086	9/18/01	Chu			

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

EXAMINER

C. J. Arbes

DATE CONSIDERED

4/1/05

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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REFERENCE DESIGNATION		U.S. PATENT DOCUMENTS					
EXAMINER INITIALS		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPRO.)
<i>CJA</i>	AA	3,812,442	05/21/74	Muckelroy			
<i>CJA</i>	AB	5,389,428	02/14/95	Fleming et al.			
<i>CJA</i>	AC	5,610,569	03/11/97	Hwang et al.			
<i>CJA</i>	AD	5,945,902	08/31/99	Lipkes et al.			
<i>CJA</i>	AE	6,008,102	12/28/99	Alford et al.			
<i>CJA</i>	AF	6,008,151	12/28/99	Sasaki et al.			
<i>CJA</i>	AG	6,104,272	08/15/00	Yamamoto et al.			
<i>CJA</i>	AH	6,147,573	11/14/00	Kumagai et al.			

FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
							YES NO

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)	
<i>CJA</i>	AI IBM Technical Disclosure Bulletin, Vol. 29, No. 2, July 1986 entitled, "Method Of Fabricating Deflection Coils For Electron Lithography Systems"

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